

As a below named inventor, I hereby declare that:

My residence, post office address and citizenship are as stated below next to my name,

I believe I am the original, first and sole inventor (if only one name is listed below) or an original, first and joint inventor (if plural names are listed below) of the subject matter which is claimed and for which a patent is sought on the invention entitled:

SELF ALIGNED METHOD OF FORMING A SEMICONDUCTOR MEMORY ARRAY OF FLOATING GATE MEMORY CELLS WITH CONTROL GATE SPACERS, AND A MEMORY ARRAY MADE THEREBY

the specification of which (check one) X is attached hereto or was filed on as

Application No	and was amen	ded on	(if applicable).
	e reviewed and understa amended by any amend	nd the contents of the above-ider ment referred to above.	ntified specification,
I acknowledge the duty 1.56.	to disclose all informati	on which is material to patentabi	lity as defined in 37 CFR §
application(s) for patent designated at least one of	t or inventor's certificate country other than the U for patent or inventor's o	5 U.S.C. § 119(a)-(d) or § 365(b), or § 365(a) of any PCT International States, listed below and have the certificate having a filing date be	tional application which we also identified below
Prior Foreign Application	Priority Claimed Yes No		
Number	Country	Day/Month/Year Filed	
Number	Country	Day/Month/Year Filed	
I hereby claim the bene	fit under 35 U.S.C. § 11	9(e) of any United States provisi	onal application(s) below.
60/234,314	September	20, 2000	
Application Number	Filing Date		
60/233,988	September	20, 2000	
Application Number	Filing Date		
60/242,096	October 19	2000	

I hereby claim the benefit under 35 U.S.C. § 120 of any United States application(s), or § 365(c) of any PCT International application designating the United States, listed below and, insofar as the subject matter of each of the claims of this application is not disclosed in the prior United States application in the manner provided by the first paragraph of 35 U.S.C. § 112, I acknowledge the duty to disclose all information

which is material to patentability as defined in 37 CFR § 1.56 which became available between the filing date of the prior application and the national or PCT international filing date of this application:

Application Number	Filing Date	Status: Patented, Pending, Abandoned	
-		. see	
Application Number	Filing Date	Status: Patented, Pending, Abandoned	
on information and belief are knowledge that willful false	e believed to be true; statements and the lik I and that such willfu	f my own knowledge are true and that all statements made and further that these statements were made with the se so made are punishable by fine or imprisonment or all false statements may jeopardize the validity of the	
Full name of sole or first inv	entor <u>Chih</u>	a Hsin Wang	
Inventor's signature			
		Date	
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